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Docket No. F-7041

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kiyohiko TAKAGI, et al.
Serial No. : 09/892,023
Filed : June 26, 2001
For : DRYING ETCHING METHOD
Group Art Unit : 2823
Examiner : William D. Coleman
Confirmation No. : 1827
Customer No. : 000028107

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AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

11/22/2004 AWONDAF1 00000083 101250 09892023

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INTRODUCTORY COMMENTS:

Sir:

In response to the final Office Action of July 15, 2004, entry of the present amendment to place the application into condition for allowance or remove issues from appeal, if required, is respectfully requested. Please amend the above-identified patent application as follows: